



IFW

Docket No.: 60188-835

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Takumi MIKAWA, et al.	:	Confirmation Number: 4685
	:	
Application No.: 10/823,797	:	Group Art Unit: 2811
	:	
Filed: April 14, 2004	:	Examiner: Not yet assigned
	:	

For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was first cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the

10/823,797

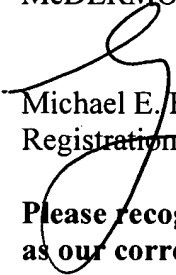
foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Also transmitted herewith is a copy of the first page of the international published application for the Examiner's information.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP



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**Please recognize our Customer No. 20277
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INFORMATION DISCLOSURE CITATION IN AN APPLICATION

ATTY. DOCKET NO.
60188-835

SERIAL NO.
10/823,797

APPLICANT
Takumi MIKAWA, et al.

FILING DATE
April 14, 2004

GROUP
2811

(PTO-1449)

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes -Number & -Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
		EP 1298730 A2	4-2-2003	MATSUSHITA ELECTRIC INDUSTRIAL CO LTD		English Abstract	
		JP 2002-110931 A	4-12-2002	MATSUSHITA ELECTRIC INDUSTRIAL CO LTD		English Abstract	
		JP 2003-68987 A	3-7-2003	MATSUSHITA ELECTRIC INDUSTRIAL CO LTD		English Abstract	
		JP 2001-7303 A	1-12-2001	TOSHIBA CORP		English Abstract	
		JP 11-126881 A	5-11-1999	HITACHI, LTD		English Abstract	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.